



PATENT
81877.012

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiyo NAKASHIMA

Serial No: 09/816,643

Filed: march 23, 2001

For: SUBSTRATE PROCESSING
APPARATUS AND SUBSTRATE
PROCESSING METHOD

Art Unit: 1763

Examiner: Kackar, Ram N.

I hereby certify that this correspondence
is being deposited with the United States
Postal Service with sufficient postage as
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450, on
October 10, 2003

Date of Deposit

Ying Chen, Reg. No. 50,193

Name

Signature *Ying Chen* October 10, 2003

Signature

Date

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the
Commissioner for a three-month extension of time extending to October 10, 2003,
the period for response to the Office Action dated April 10, 2003. A check for
\$950.00 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account
No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: October 10, 2003

By: *Ying Chen*
Ying Chen
Registration No. 50,193
Attorney for Applicant(s)

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